



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Volker Haerle Art Unit : Unknown Serial No. : 10/625,118 Examiner : Unknown

Filed : July 22, 2003

Title : METHOD OF PRODUCTION OF SEMICONDUCTOR COMPONENTS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Copies of the references listed on the attached form PTO-1449 are enclosed.

This statement is being filed within three months of the filing date of the application or before the receipt of a first Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date:	8/	14	- 1	103
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## CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 223131450.

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	Substitute Form PTO-1449	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 12406-059US2	Application No. 10/625,118	
/	Information Discl	licant	Applicant Volker Haerle		
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U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
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Foreign Patent Documents or Published Foreign Patent Applications								
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Other Documents (include Author, Title, Date, and Place of Publication)					
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	AQ	B. Henle, et, al., "In Situ Selective Area Etching and Movpe Regrowth Of Gains As-InP ON InP Substrates," Int. Conf. On Indium Phosphide & Rel. Materials, U.S. NY, IEEE, Bd. CONF 4, S. pgs. 159-162			
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EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with					
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